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1763

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By

Eric L. Maldonado

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Attorney Docket No. NECW 18.159 (100806-17346)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Atsushi NISHIZAWA  
Serial No.: 09/751,979  
Filed: December 29, 2000  
Title: MANUFACTURING METHOD...  
Examiner: George A. Goundreau  
Art Unit: 1763

November 24, 2003

Director of the U.S. Patent and  
Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

S I R:

In order to comply with discretionary rules 37 CFR §§1.97 and 1.98, attached hereto is a copy of Form PTO-1449 and copy of the document listed thereon. This document contains information in which the Examiner may consider to be important in deciding whether to issue a patent in the instant application.

As this statement is being filed after the filing of a request for continued examination under §1.114 and before the mailing of a first Office Action, no fee is due.

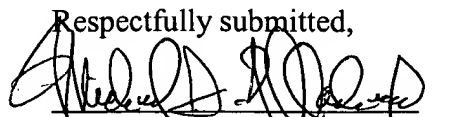
The present Information Disclosure Statement is being submitted in compliance with 37 §CFR 1.56 as an Examiner might consider any cited document important in deciding whether to allow the application to issue as a patent, but the citation of each document is not to be construed as an admission that such document is necessarily relevant or prior art. No representation is

intended that the cited documents represent the results of a complete search, and it is anticipated that the Examiner in the normal course of examination, will make an independent search and will determine the best prior art consistent with 37 CFR 1.104 (a), and in the course of such search will review for relevance every document cited on the attached form even if not initialed.

Early and favorable consideration is respectfully solicited.

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Respectfully submitted,



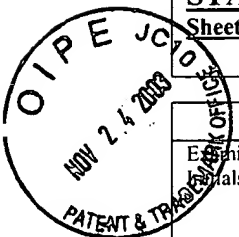
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1449/PTO	U.S. Department of Commerce Patent and Trademark Office	Application No. : 09/751,979
		Filing Date : December 29, 2000
<b>INFORMATION DISCLOSURE</b>		First Named Inventor: A. NISHIZAWA
<b>STATEMENT BY APPLICANT</b>		Group Art Unit : 1763
Sheet 1 of 1		Examiner Name : G.A. GOUNDREAU
		Attorney Docket No. : NECW 18.159



### U.S. PATENT DOCUMENTS

Examiner Initials	Cite No. <sup>1</sup>	U.S. Patent Document	Kind Code if known <sup>2</sup>	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD- YYYY	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear

### FOREIGN DOCUMENTS

Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document Office <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Country	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YY/Y	Pages, Columns Lines Where Relevant Passages or Relevant Figures Appear

### Other Prior Art-Non Patent Literature Documents

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), data, page(s), volume-issue number(s), publisher, country, where published, source.	Applicant check here if English language translation attached
		WOLF et al., "SILICON PROCESSING FOR THE VLSI ERA" VOLUME 1: PROCESS TECHNOLOGY 1986 ISBN: 0-961672-3-7, pp. 550-553	
Examiner Signature	Date Considered		

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